

FIG. 1A

PRIOR ART

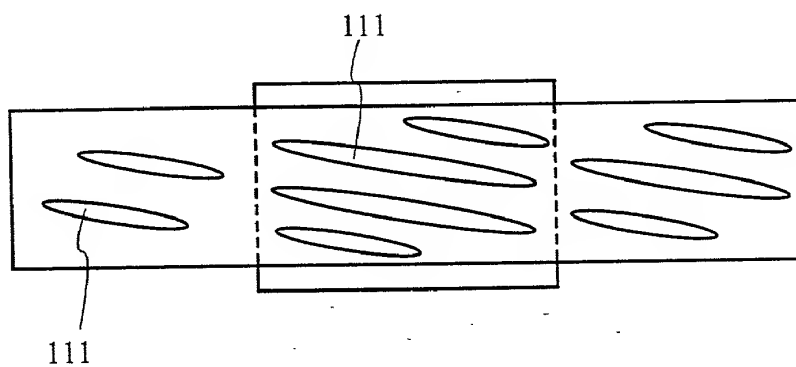
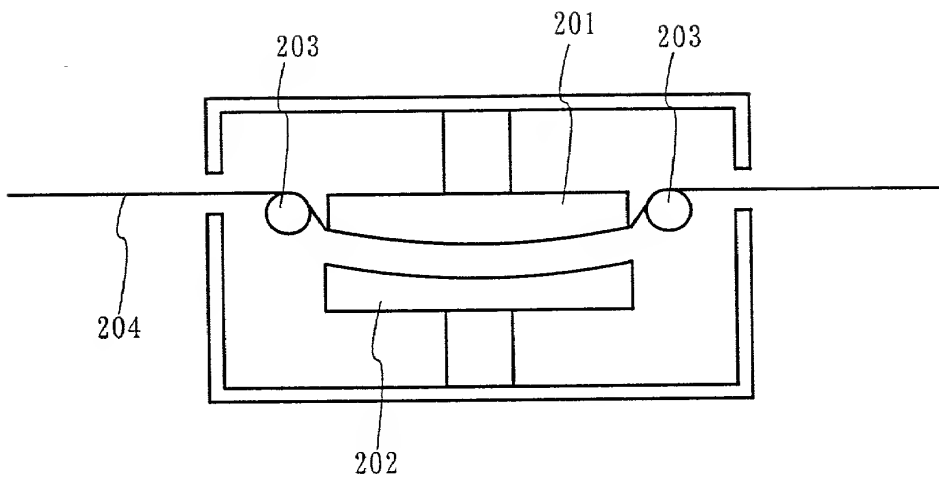


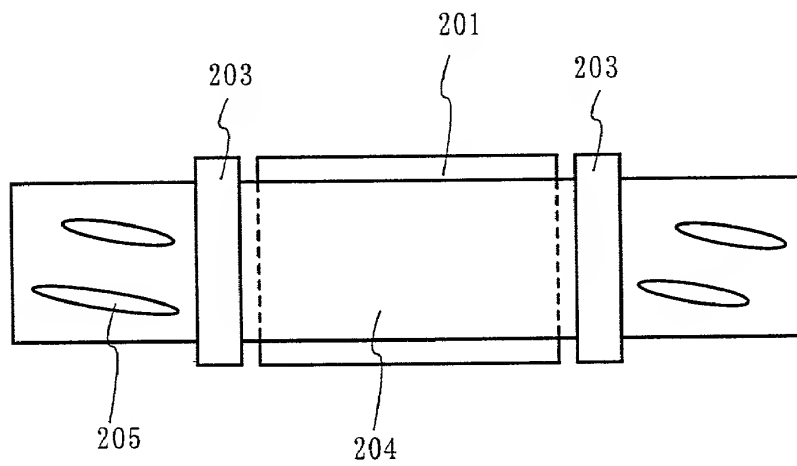
FIG. 1B

PRIOR ART



PRIOR ART

FIG. 2A



PRIOR ART

FIG. 2B

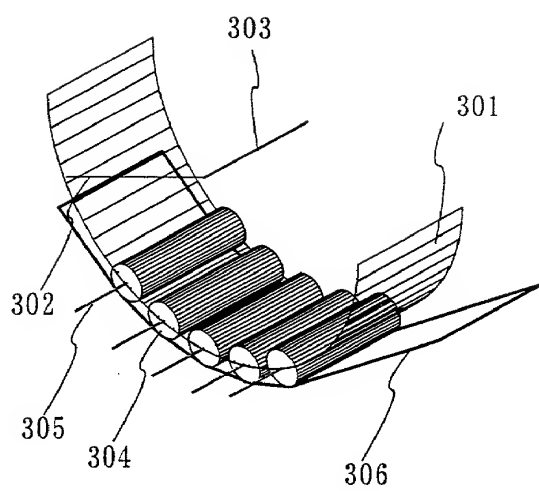


FIG. 3

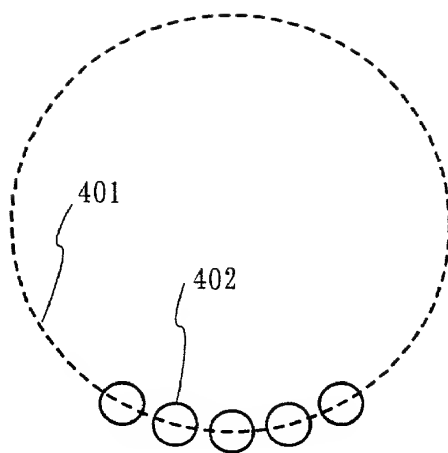


FIG. 4A

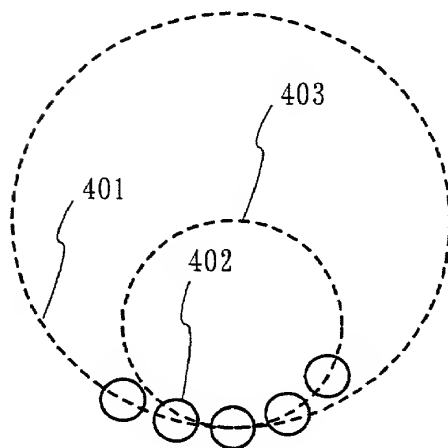


FIG. 4B

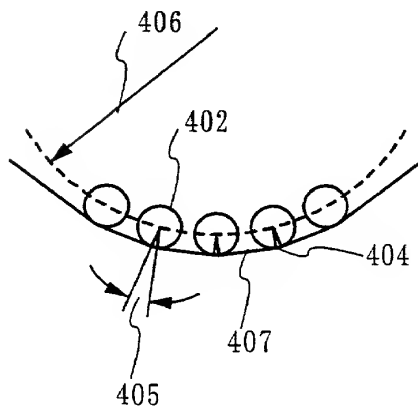
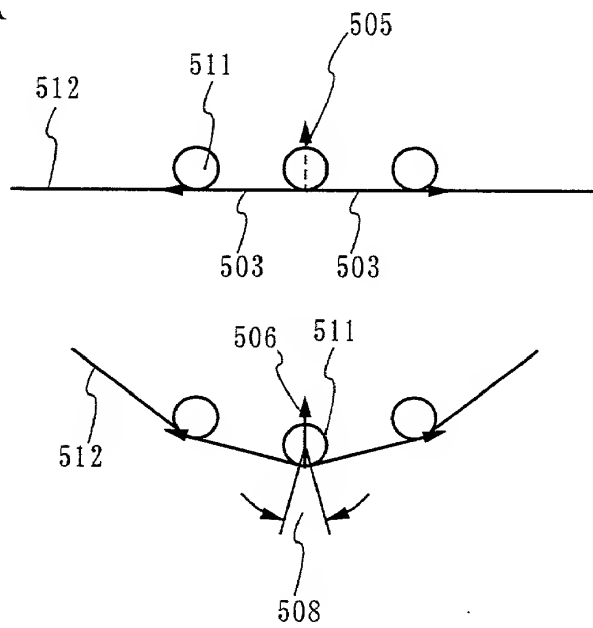
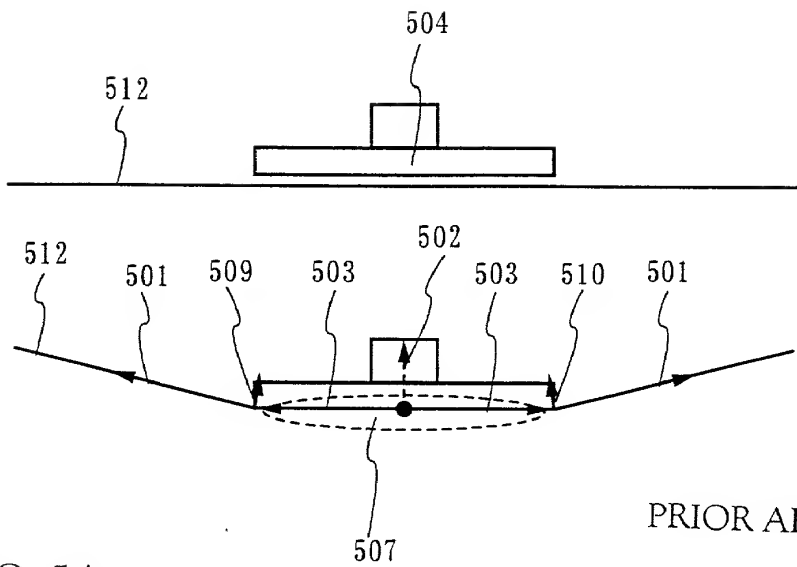


FIG. 4C



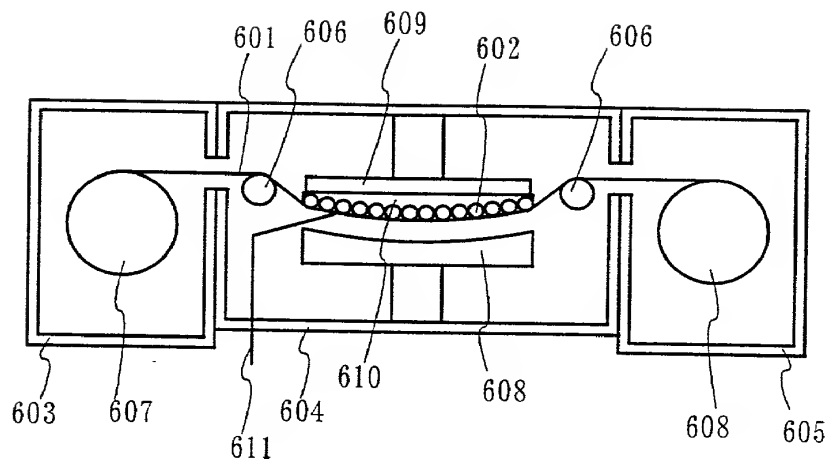


FIG. 6A

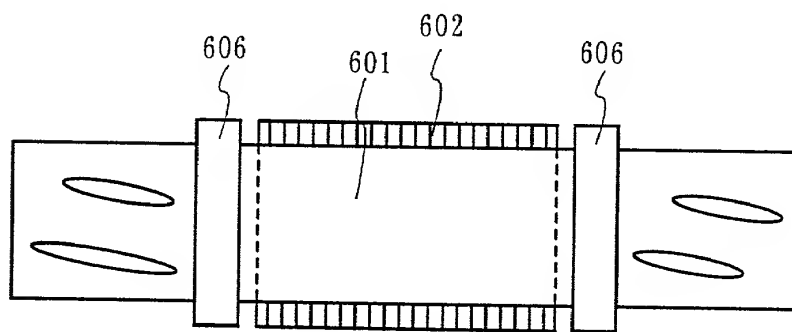


FIG. 6B

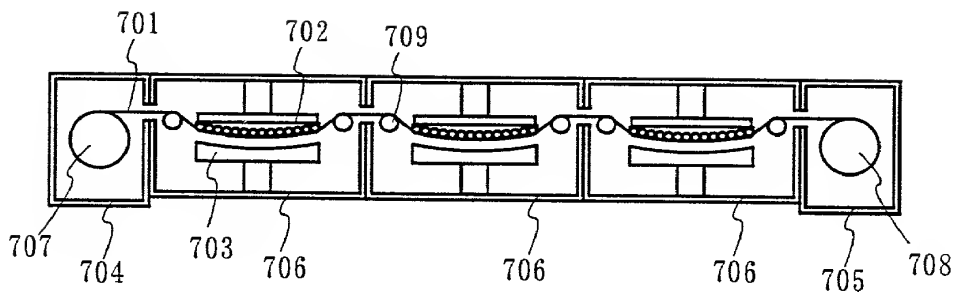


FIG. 7A

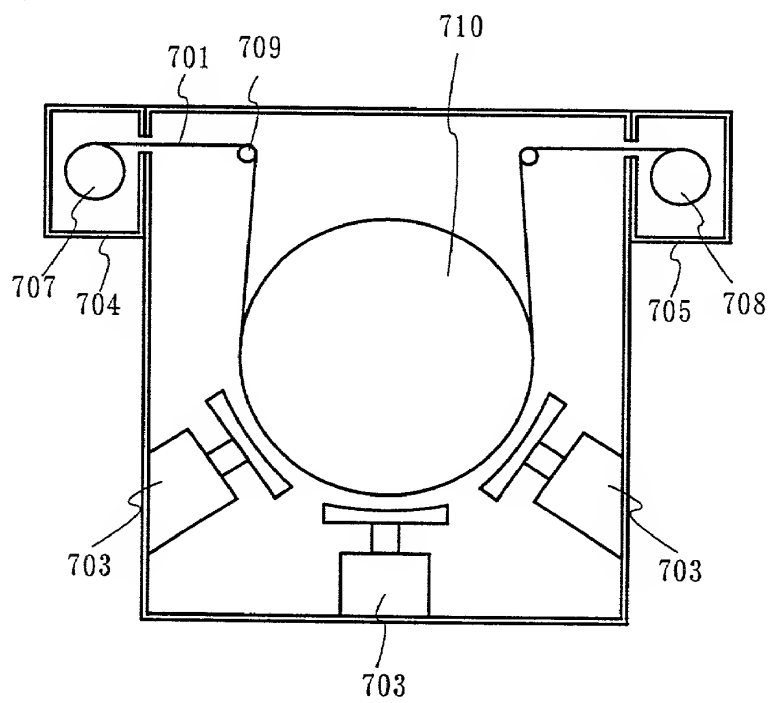


FIG. 7B

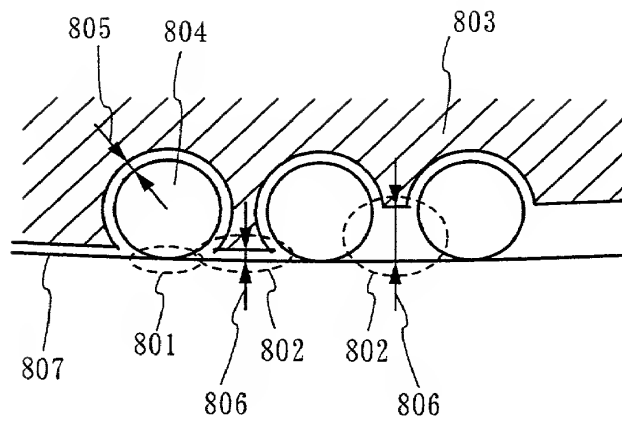


FIG. 8

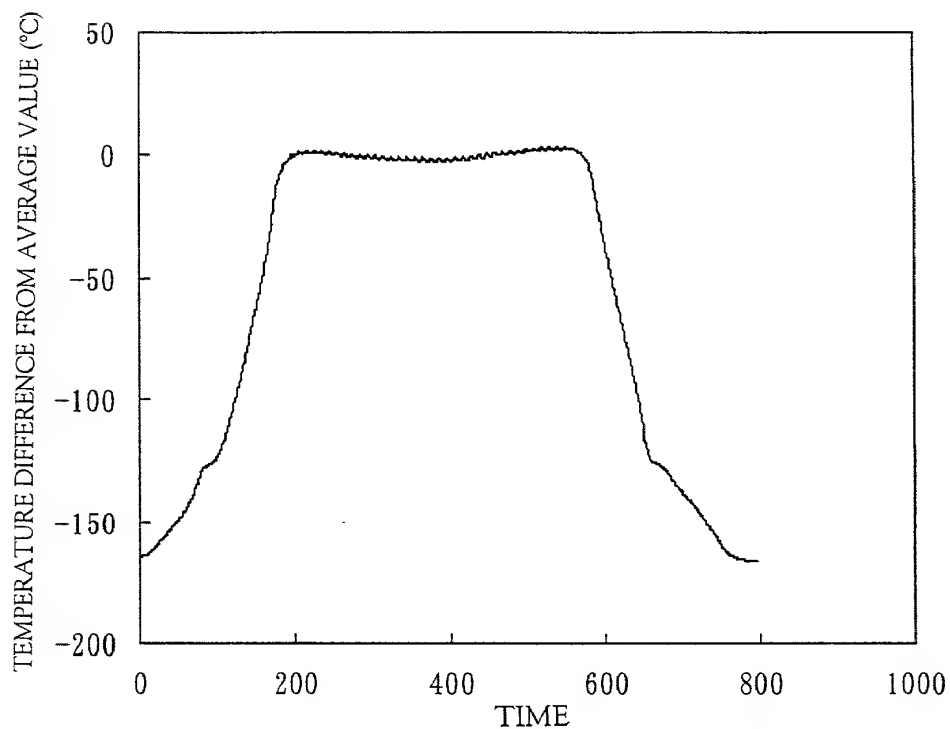


FIG. 9A

MEASUREMENT OF TEMPERATURE OF
CURVED SURFACE ROLLER METHOD ELECTRODE

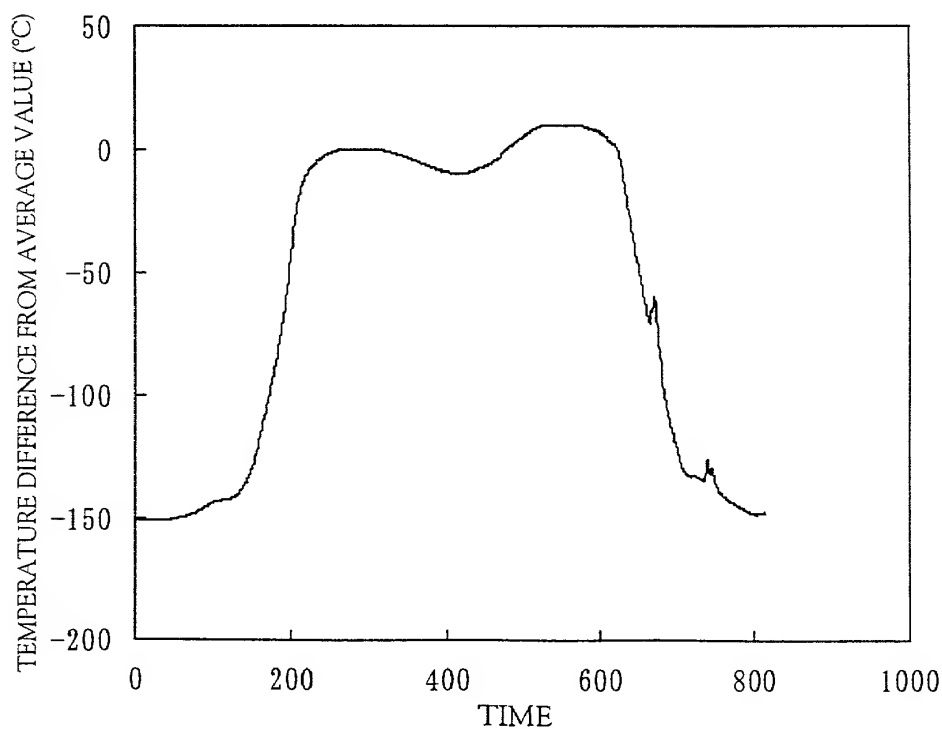


FIG. 9B

MEASUREMENT OF TEMPERATURE OF
PARALLEL PLATE METHOD ELECTRODE

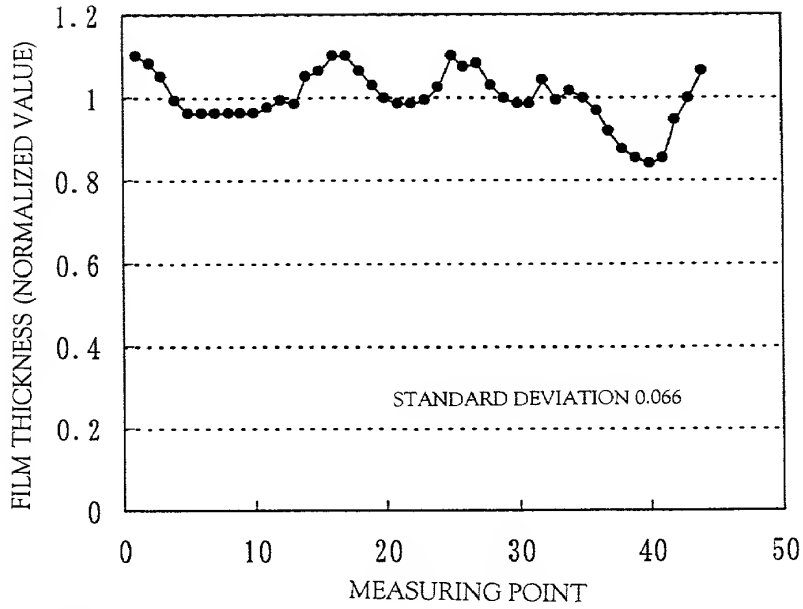


FIG. 10A FILM FORMATION WITH PARALLEL PLATE METHOD ELECTRODE AND MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION

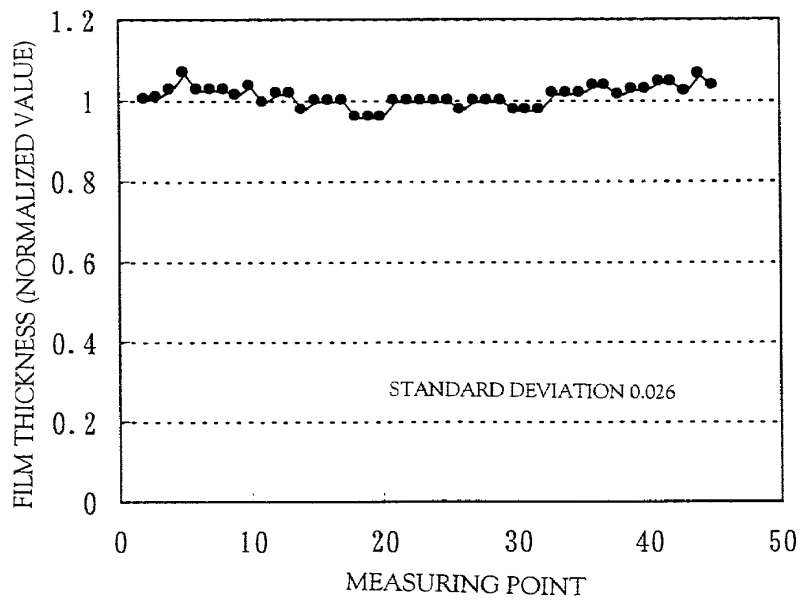


FIG. 10B FILM FORMATION WITH CURVED SURFACE ROLLER METHOD ELECTRODE AND MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION